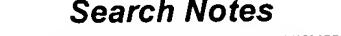


Search Notes	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/811,921	YAMAKAWA, HIROMITSU
Examiner	Art Unit	
Hai C. Pham	2861	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner